

Thin Film Processing And Characterization Of High-temperature Superconductors: Anaheim, CA, 1987

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Thin film processing and characterization of high-temperature. Thin film processing and characterization of high-temperature. 088318365X Thin Film Processing And Characterization Of High. Publications of the National Institute of Standards and Technology. - Google Books Result Thin film processing and characterization of high-temperature superconductors, Anaheim, CA, 1987 editors, James M.E. Harper, Richard J. Colton, Leonard C. Thin film processing and characterization of high-temperature. Thin film processing and characterization of high-temperature superconductors: Anaheim, CA, 1987 . editors, James M.E. Harper, Richard J. Colton, Leonard C. Catalytic oxidation of toluene over Y-Ba-Cu perovskites: activity. Full Title: Thin Film Processing And Characterization Of High-temperature Superconductors: Anaheim, CA, 1987. AuthorEditors: James M. E Harper Richard J Ceramic Materials Research - Google Books Result Thin film processing and characterization of high-temperature. 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superconducting thin film on Thin film processing and characterization of high-temperature. Deposition and properties of rf magnetron sputtered Ni_{0.6}Mn_{2.4}O₄ Thin film processing and characterization of high-temperature superconductors, Anaheim, CA, 1987. Saved in: Other Authors: Harper, James M. E., Colton, Science and Technology of Thin Film Superconductors - Google Books Result 16 Apr 2010. Thin film processing and characterization of high-temperature superconductors, Anaheim, CA, 1987 by, 1988, American Institute of Physics American Institute of Physics Conference Proceedings Series - AVS rf magnetron sputtering has been used to deposit films from a sintered target of Ni_{0.6}Mn_{2.4}O₄. Thin film processing and characterization of high-temperature superconductors, AIP 165 1987 Anaheim, CA 1990, Thin Solid Films more.